



Attorney Docket No.: SAM-0526  
Application Serial No.: 10/796,507  
Reply to Office Action of: February 16, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al* Examiner: El Arini, Zeinab  
Serial No.: 10/796,507 Group Art Unit: 1746  
Filing Date: March 9, 2004  
Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR  
SUBSTRATES (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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04/12/06

Date

Christina Harris

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

The following is in response to the Office Action dated February 16, 2006, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.